

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

MIZUHARA et al.

Serial No.: 09/037,674

Filed: March 9, 1998

Atty. File No.: 2933SE-11-CIP-2

For: "SEMICONDUCTOR DEVICES
PASSIVATION FILM"

Assistant Commissioner for Patents
Washington, D.C. 20231

Group Art Unit: 2814

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SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT

CERTIFICATE OF MAILING

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SHERIDAN ROSS P.C.

BY:

Brenda Carpenter

Dear Sir:

Pursuant to Applicants' duty of disclosure under 37 CFR § 1.56 and 37 CFR §§ 1.97-1.98, Applicants hereby submit the enclosed PTO Form 1449. The documents identified herein were of record in U.S. Patent Application Serial No. 08/766,931, and since the above-identified patent application is a continuation thereof, copies of the identified documents are not being submitted under 37 CFR § 1.98(d). Applicants do not admit that any of such documents, alone or in any combination, is considered to be material to patentability as defined in 37 CFR § 1.56(b). Moreover, the inclusion of these documents is not to be construed as an admission by Applicants that each such document is prior art as to the above-identified patent application.

Respectfully submitted,

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